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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Eun -Kyung Lee Conf. No.: 5019  
Application No.: 10/758,136 Examiner: Laura M. Schillinger  
Filing Date: January 16, 2004 Art Unit: 2813  
Title: METHOD OF MANUFACTURING SILICON OPTOELECTRONIC DEVICE, SILICON OPTOELECTRONIC DEVICE MANUFACTURED BY THE METHOD AND IMAGE INPUT AND/OR OUTPUT APPARATUS USING THE SILICON OPTOELECTRONIC DEVICE  
Attorney Docket: 2557SI-001230/US/CPA

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314  
**Mail Stop Amendment**

January 20, 2010

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Sir/Madam:

In response to the Office Action mailed September 20, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Specification** begin on page 2 of this paper.

**Listing of the Claims** begin on page 3 of this paper.

**Remarks** begin on page 10 of this paper.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
<b>Total</b>	35	-	35	=	0
<b>Independent</b>	2	-	3	=	0